

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/750,027	PEDERSON, JO	OHN C.
Examiner	Art Unit	
Benjamin C. Lee	2632	

	SEARCHED				
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
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EAST (patent number searches)	9/17/2005	R	
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